

Notice of References Cited

Application/Control No.

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Applicant(s)/Patent Under
Reexamination
MURTUZA, MASOOD

Examiner

Mark A. Baumgardner

Art Unit

2826

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,650,010 B2	11-2003	Davis et al.	257/700
	B	US-			
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	E	US-			
	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	W	
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